



MS AF  
PATENT  
3430-0175P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Young-Sang BYUN et al. Conf.: 4398  
Appl. No.: 10/028,433 Group: 2871  
Filed: December 28, 2001 Examiner: T. V. DUONG  
For: METHOD OF FORMING A LIQUID CRYSTAL LAYER  
USING AN INK JET SYSTEM

*Entered Per  
RCE  
JF 11/105  
AMSB*

**AMENDMENT UNDER 37 C.F.R. § 1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

APRIL 11, 2005

Sir:

In response to the Examiner's final Office Action dated January 11, 2005, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application.

This response includes:

Claim Set as Amended; and

Remarks.